

**REMARKS:**

Claims 1 and 2 remain in the case and are presented for consideration.

As noted in the Amendment filed June 10, 2008, claims 1 and 2 have been amended to limit the invention to the measuring of parameters at the at least two separate locations on a substrate that are perpendicular to the movement direction of the substrate as shown in Fig. 2, and to define the location of the sensing apparatus (claim 1) and step (claim 2) as being spaced from the coating location where the coating takes place, along the direction of movement of the substrates along their cyclic path of movement past the sensing location and past the coating location.

In addition to the arguments presented in the last Amendment, please also consider the attached Rule 132 Declaration by the sole inventor of this patent application, Othmar Zueger (also correctly spelled Othmar Züger), who is an expert in the filed of the present invention as evidenced by his attached Resume, and is therefore familiar with the level of ordinary skill in this art.

The claims are therefore believed to be patentably distinct over the combination of the Baldwin patents and the application and claims are believed to be in condition for allowance.

Favorable action is respectfully requested and again, the Examiner is respectfully invited to telephone the undersigned if any matters remain.

Respectfully submitted,  
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